

# Synthesis and Control of Coherent Structures in Low Temperature Plasmas for Reconfigurable Electromagnetic Devices: Self-organized Plasma Lattice Metamaterial

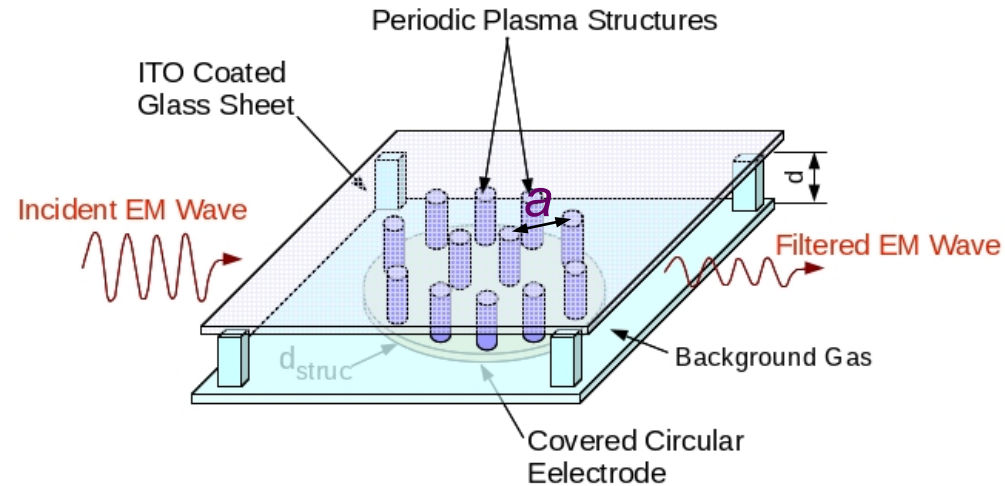
Thomas Corke and Eric Matlis

Institute for Flow Physics and Control  
Aerospace and Mechanical Engineering  
University of Notre Dame  
College of Engineering  
Notre Dame, IN  
[tcorke@nd.edu](mailto:tcorke@nd.edu)



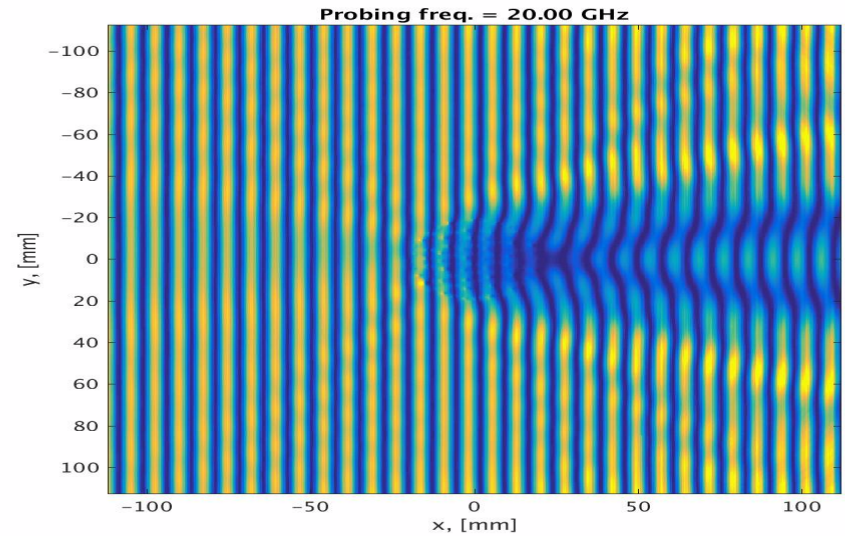
# Research Objectives

- Experimentally generate spatially periodic plasma **lattice** structures in air
  - Exploit charge instability between electrodes separated by a double dielectric layer
- Demonstrate dynamic control of plasma lattice spacing,  $a$ 
  - Document dependence on gas pressure ( $P_s$ ), gap distance ( $d$ ), and input power
- Experimentally determine EM wave transmittance under different plasma lattice conditions

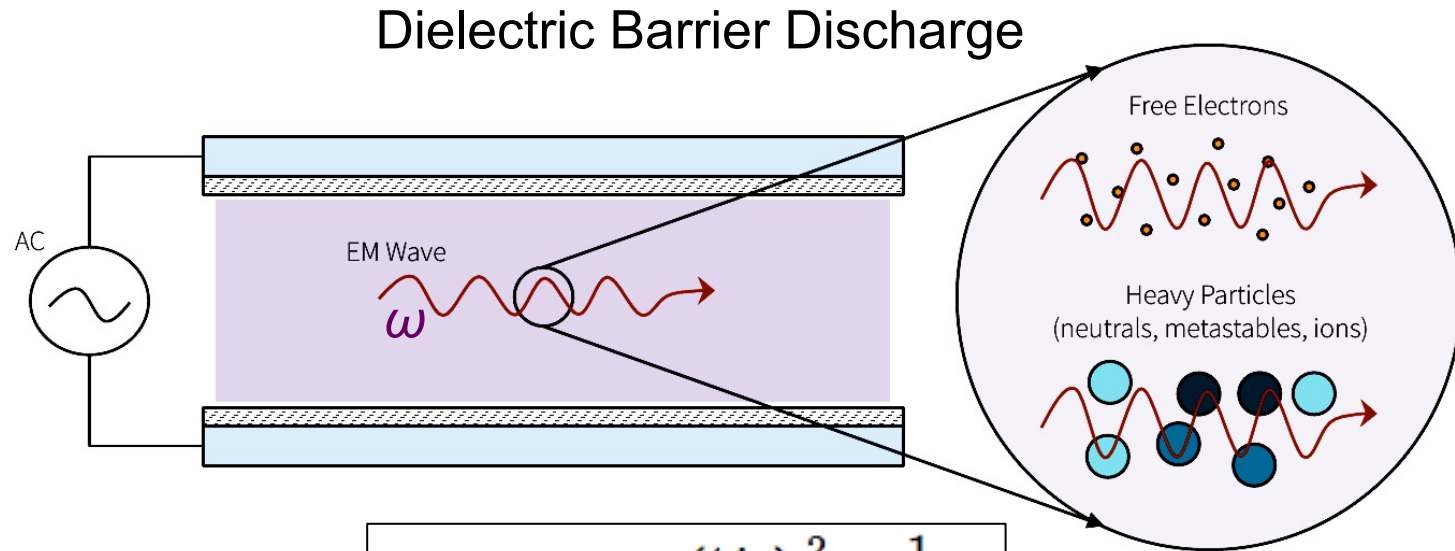


# Research Objectives

- Incorporate experimentally derived plasma lattice into EM wave simulation to determine predicted transmittance characteristics
- Compare EM transmittance obtained from experiments to EM wave simulation predictions
  - Independent variables:  $P_s$  and  $n_e$
- Use validated simulation to project EM transmittance to target 70GHz probing frequency



# Approach: Plasma Permittivity Control



Plasma Permittivity:

$$\epsilon_p(\omega) = 1 - \left(\frac{\omega_p}{\omega}\right)^2 \frac{1}{1 - i\frac{\nu}{\omega}}$$

- Plasma frequency,  $\omega_p$ , is a function of electron density, which is controllable by the **applied voltage**.
- Electron-neutrals collision frequency,  $\nu$ , is a function of the **gas pressure**.
- The combination control the plasma permittivity.

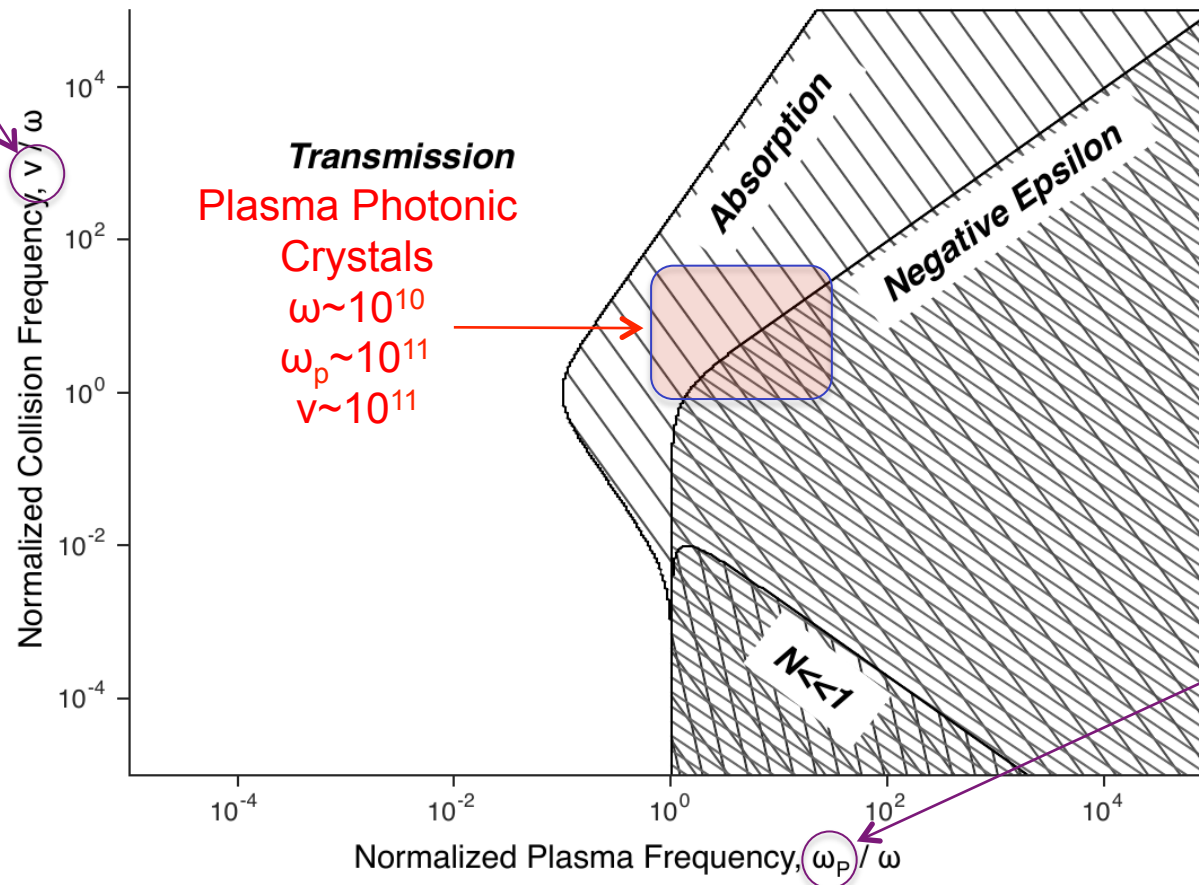


# Approach: Plasma Permittivity Regimes

Razier (1991)

$$\nu = (3.9 \times 10^9 \text{ s}^{-1} \text{ Torr}^{-1}) P_s$$

$$\epsilon_p(\omega) = 1 - \left(\frac{\omega_p}{\omega}\right)^2 \frac{1}{1 - i\frac{\nu}{\omega}}$$



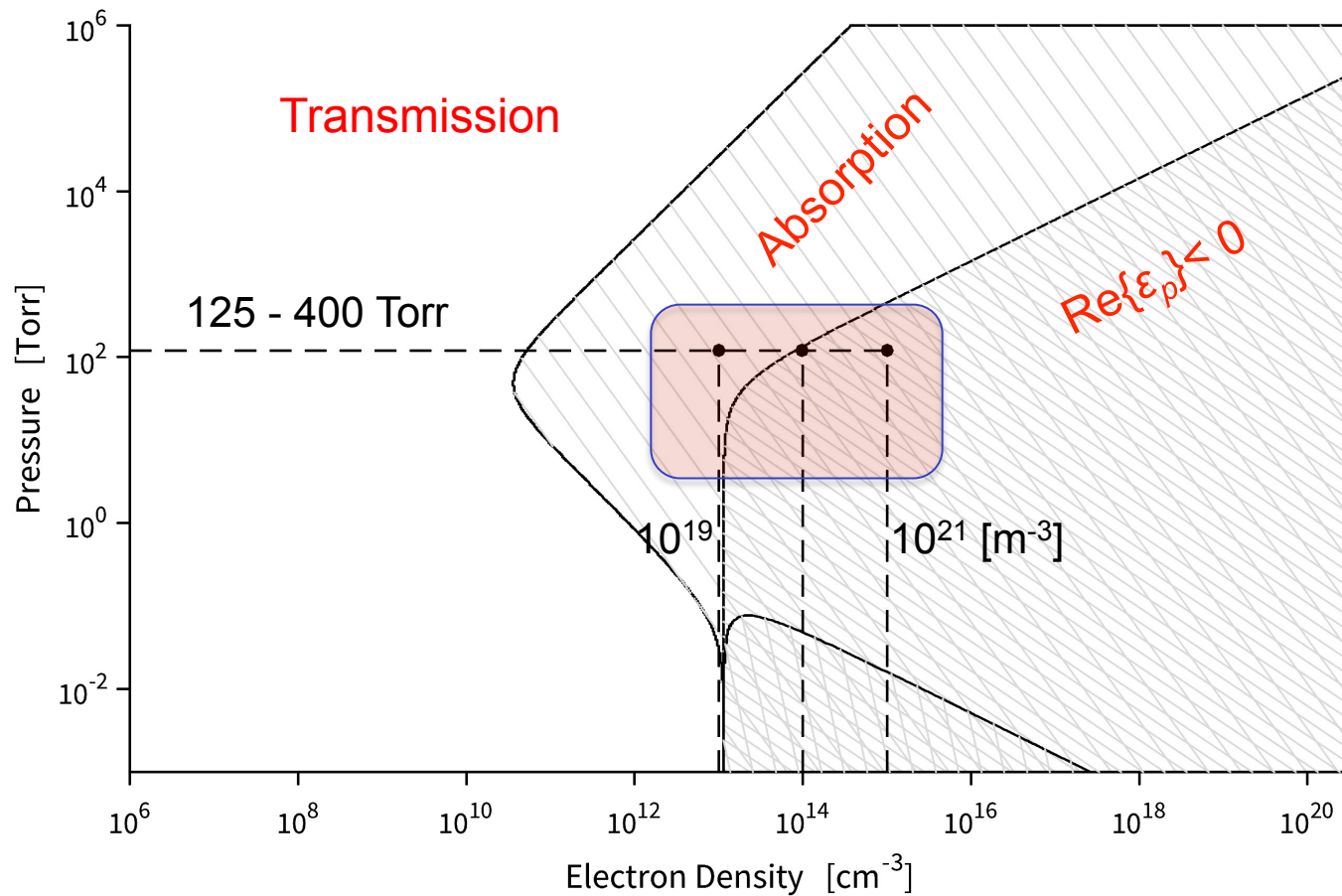
$$\omega_p = \sqrt{\frac{n_e q^2}{m \epsilon_0}}$$

# Approach: Plasma Permittivity Control

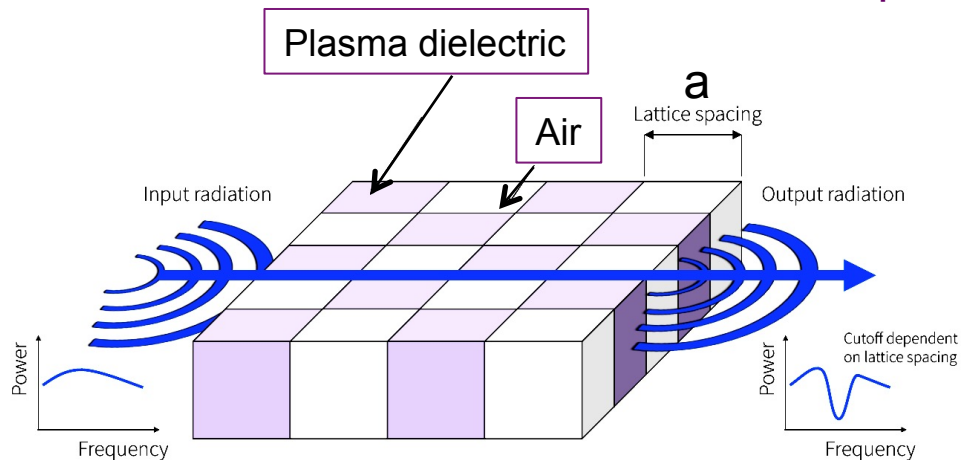
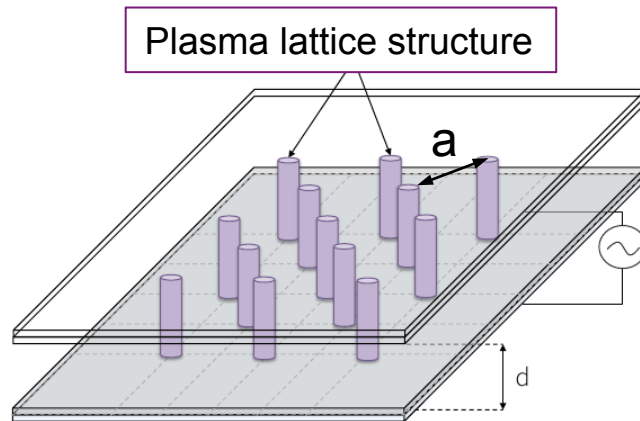
$$\omega/2\pi=20\text{GHz}$$

$$\epsilon_p(\omega) = 1 - \left(\frac{\omega_p}{\omega}\right)^2 \frac{1}{1 - i\frac{\nu}{\omega}}$$

Air

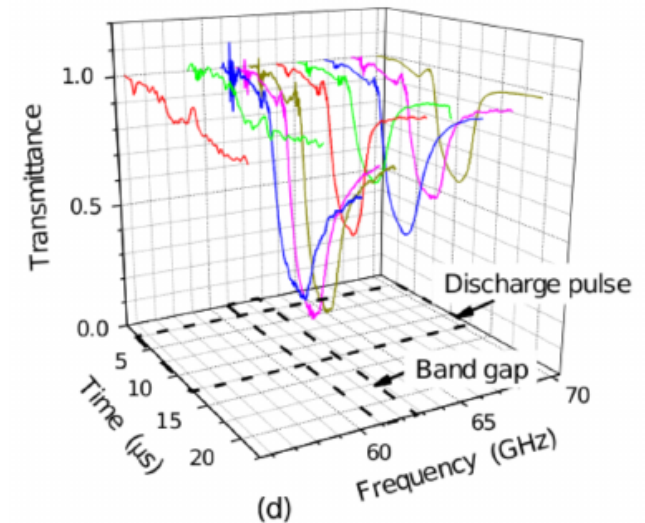


# Approach: Plasma Lattice



Simplified rectilinear lattice

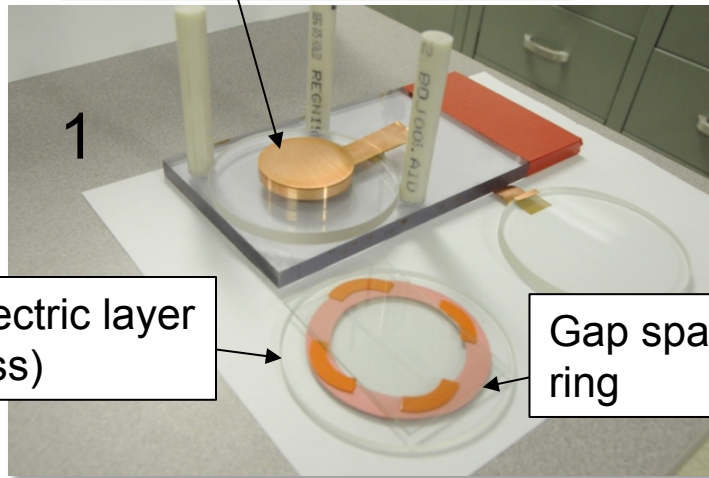
- Plasma charge instability\* produces stationary, naturally spaced **plasma lattice structure**. (\*Callegari et al., 2014)
- Forms a periodic dielectric in 2-D.
- Lattice spacing determines propagation characteristics: **frequency cut-off, photonic band gap**.



(d) Sakai & Tachibana. 2012

# Plasma Lattice Device

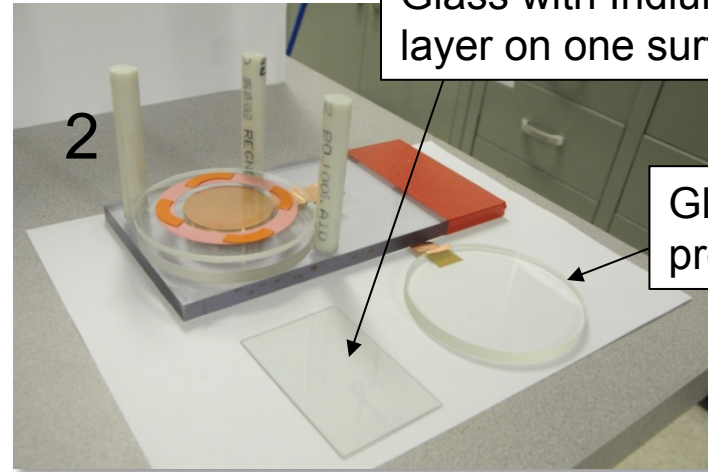
Circular Lower Electrode



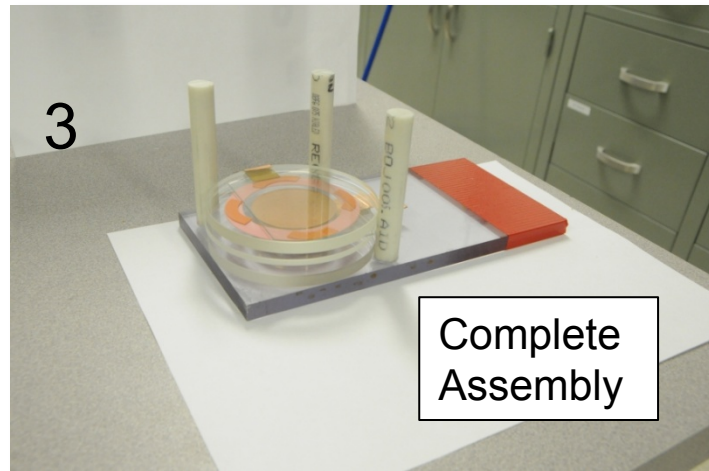
Dielectric layer (glass)

Gap spacer ring

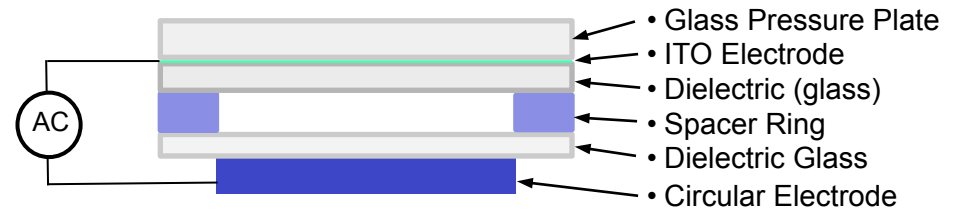
Glass with Indium-Tin-Oxide layer on one surface



Glass pressure plate



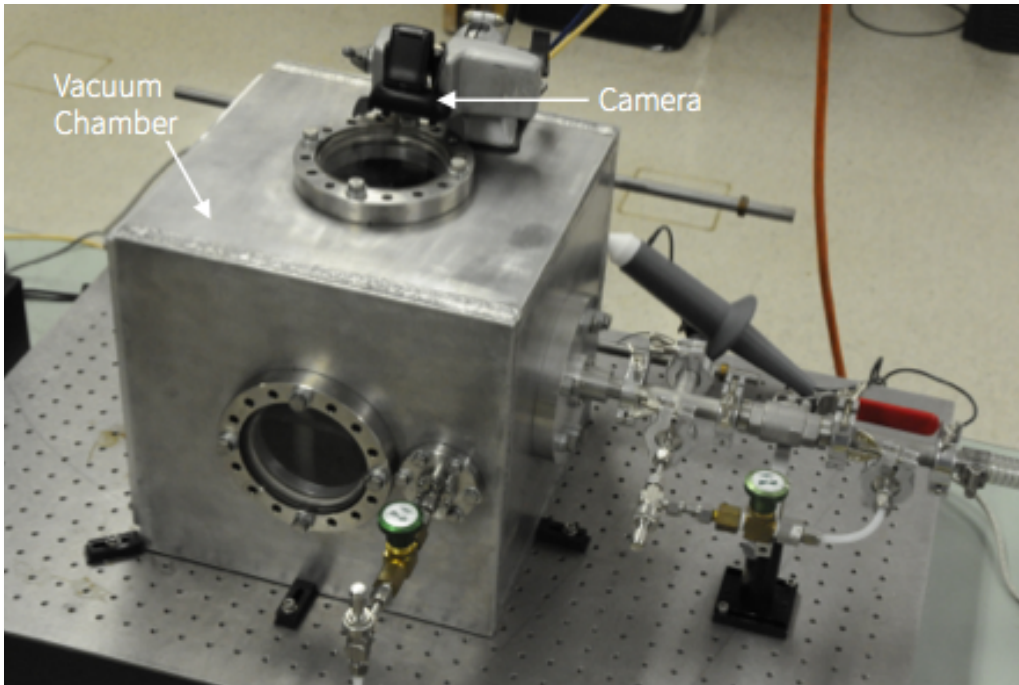
Complete Assembly



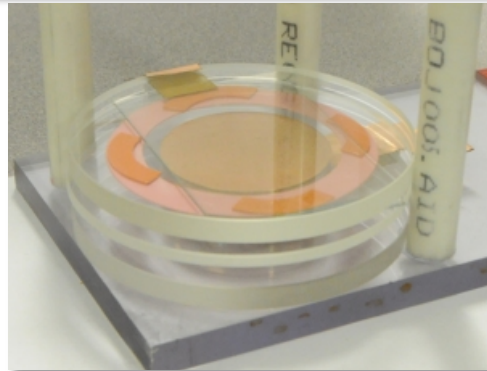
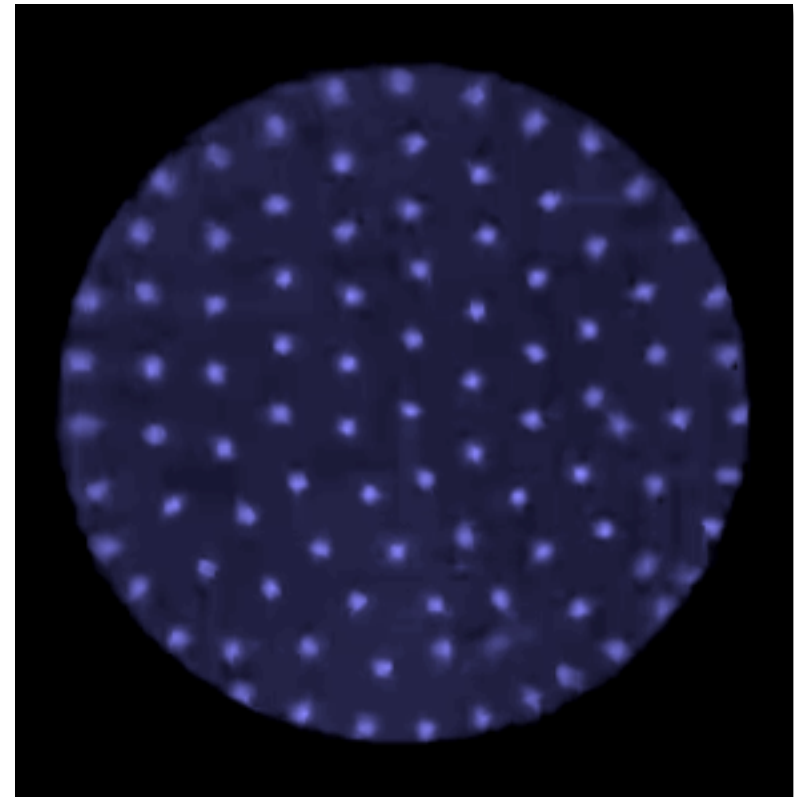
Assembly Schematic



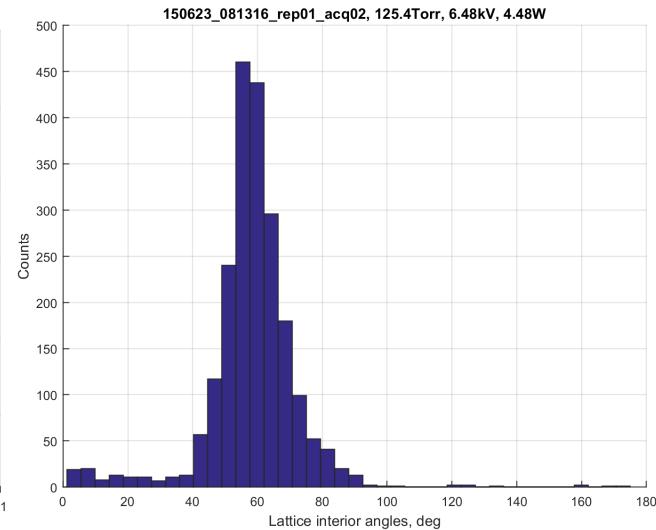
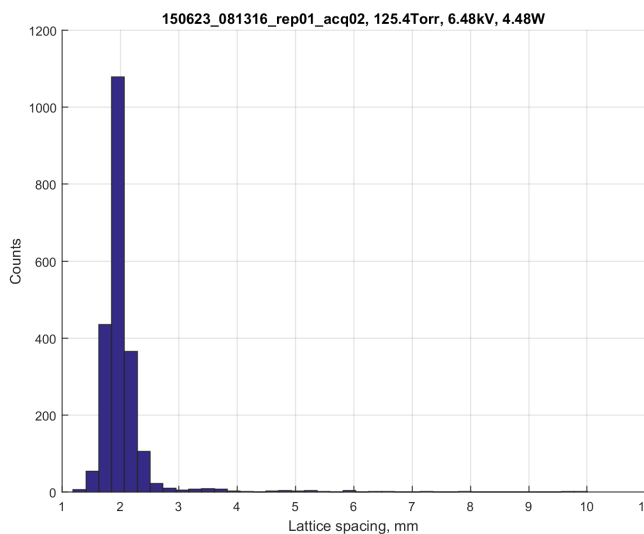
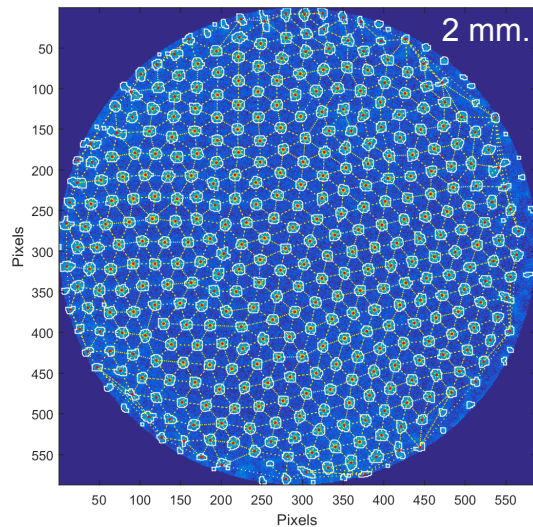
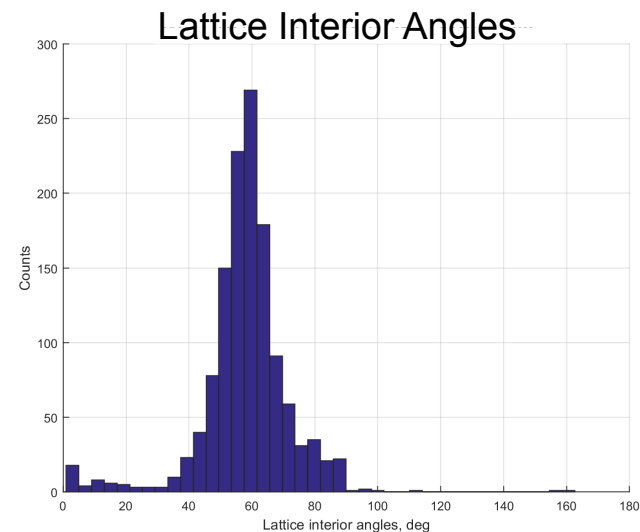
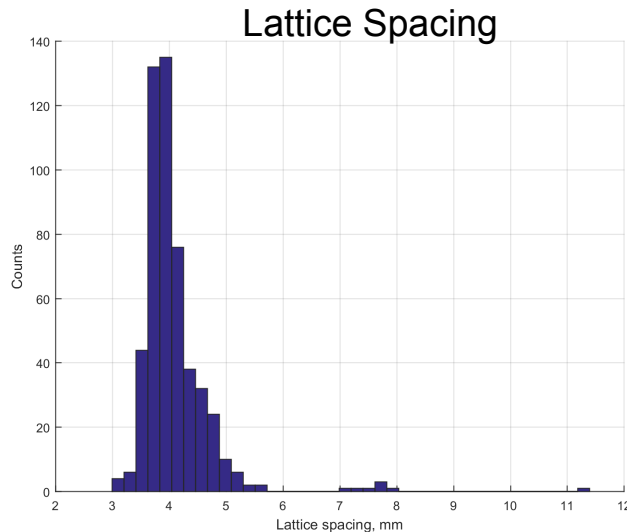
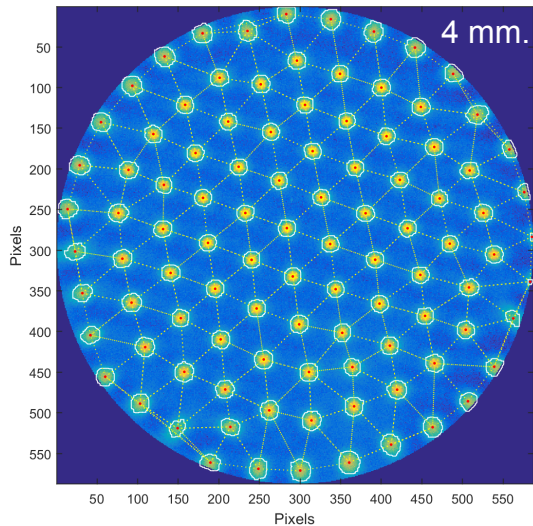
# Plasma Lattice Structure



## Effect of Voltage

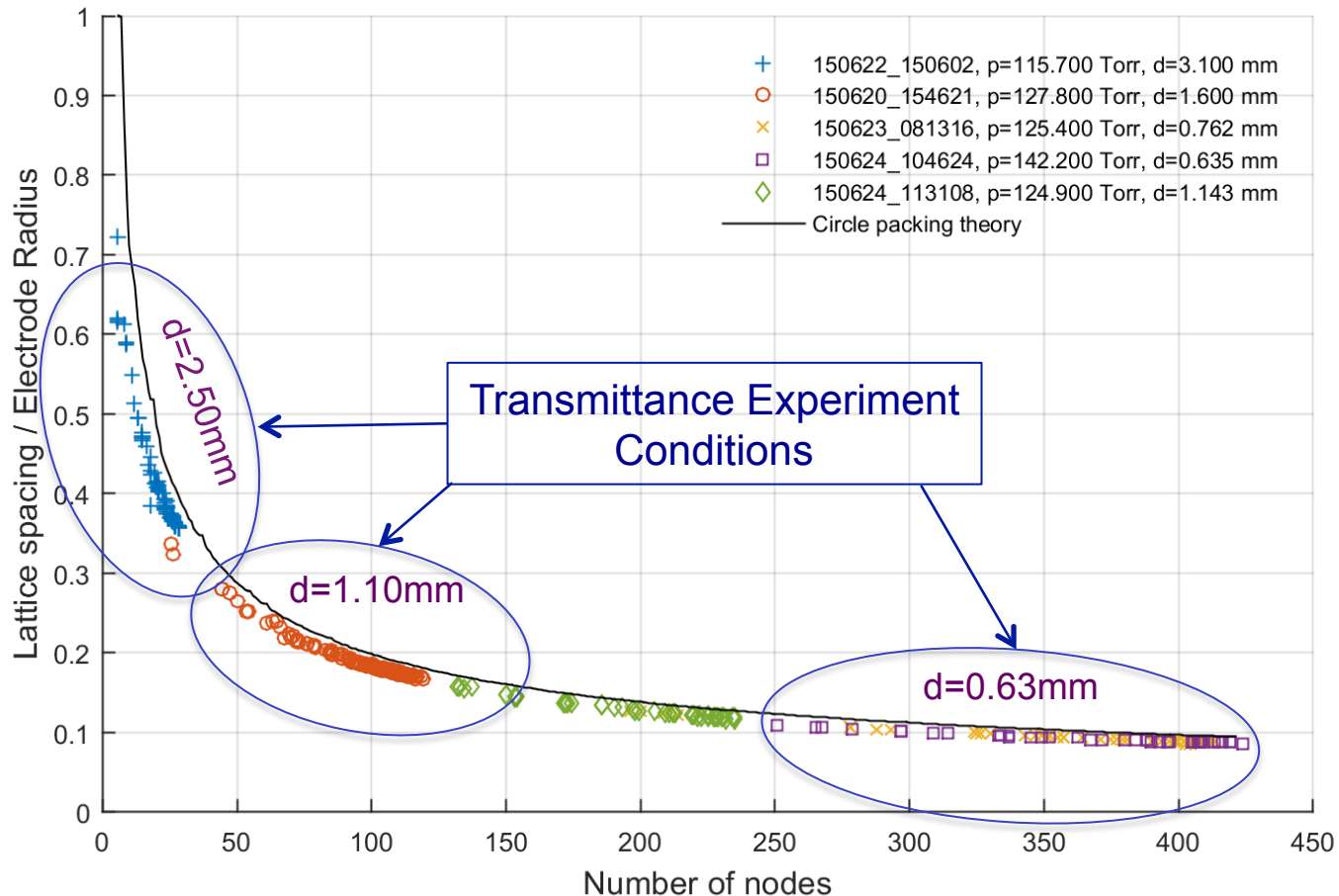


# Lattice Analysis: Node Locations, Radii and Spacing



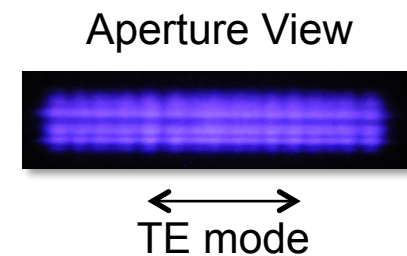
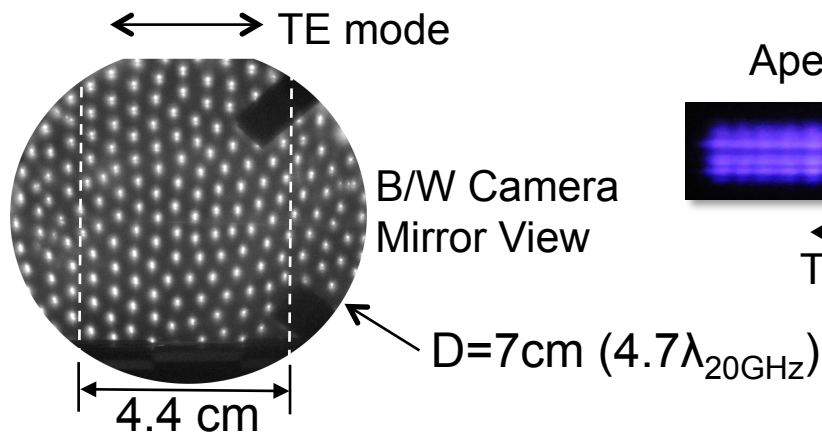
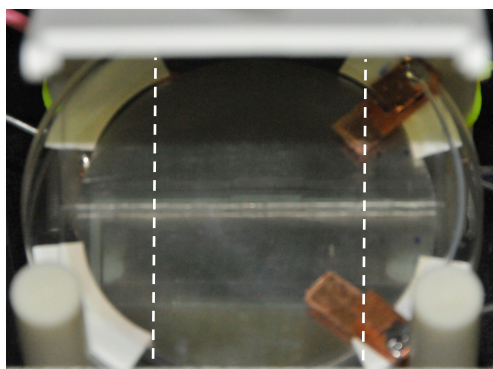
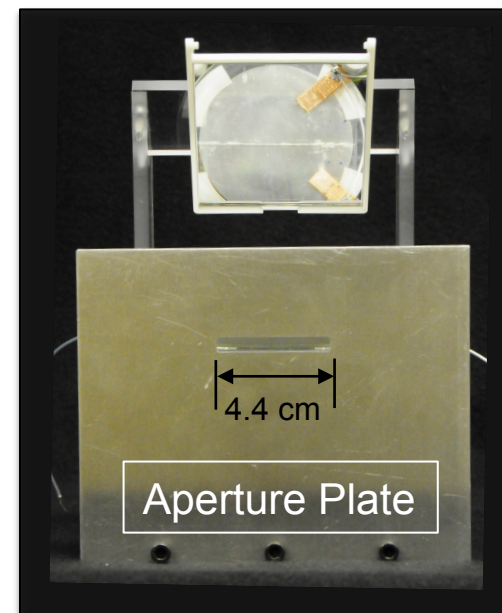
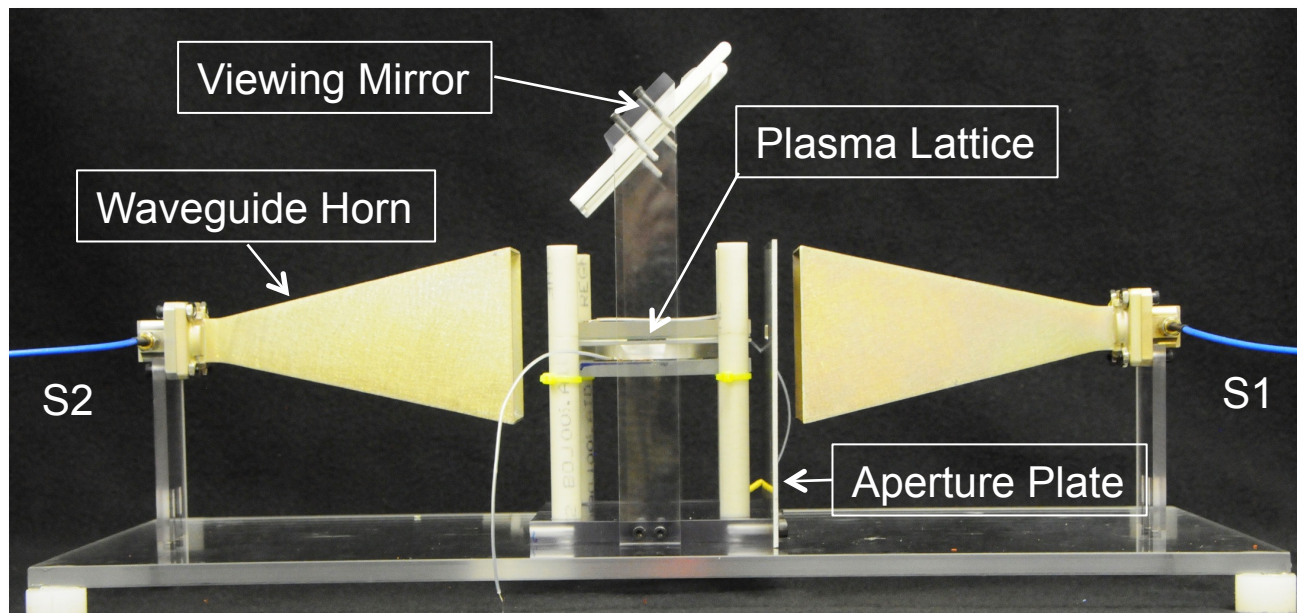
# Predictive Plasma Lattice Control

## Follows Circle Packing Theory



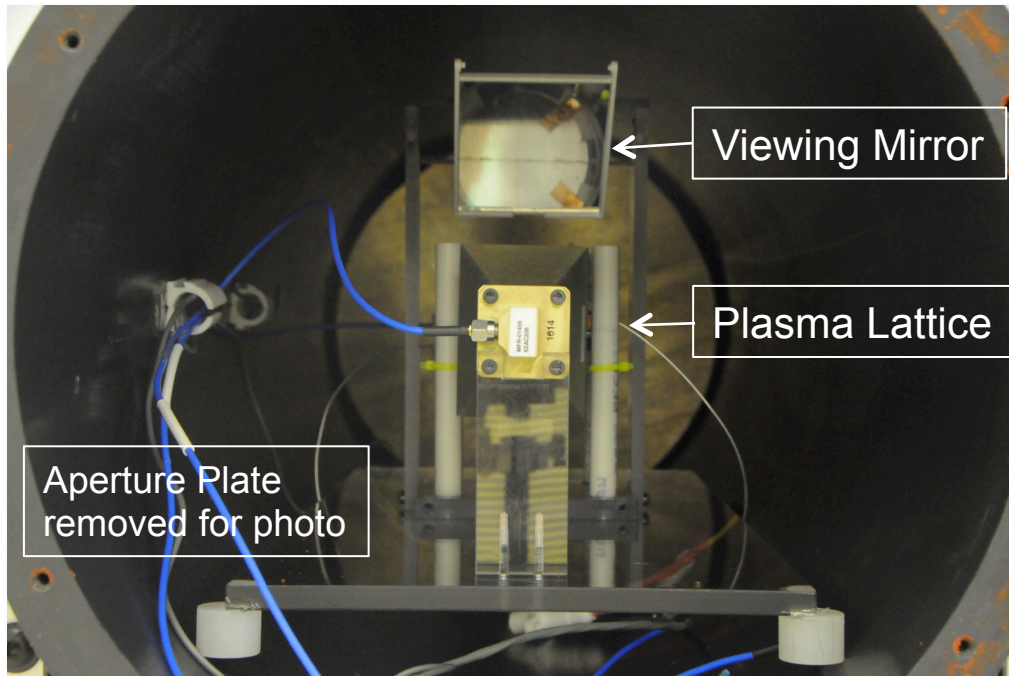


# EM Wave Experimental Setup

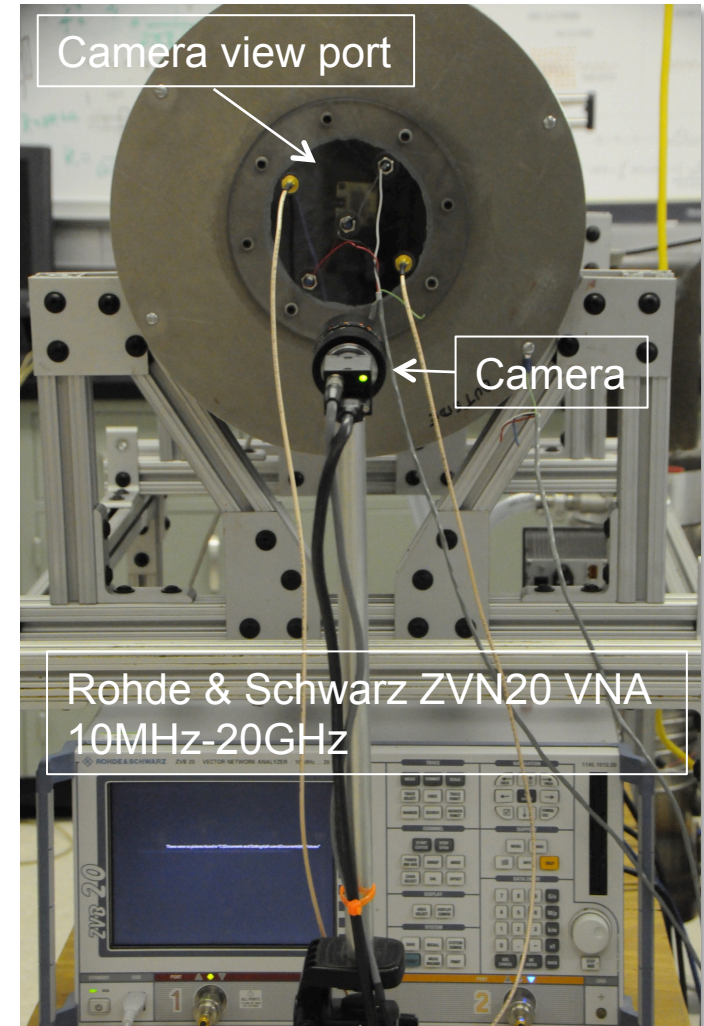




# EM Wave Experimental Setup



- Experimental setup placed in cylindrical pressure vessel
- Vacuum-rated electrical pass-through connectors for plasma power, and S1 and S2 analyzer signals.

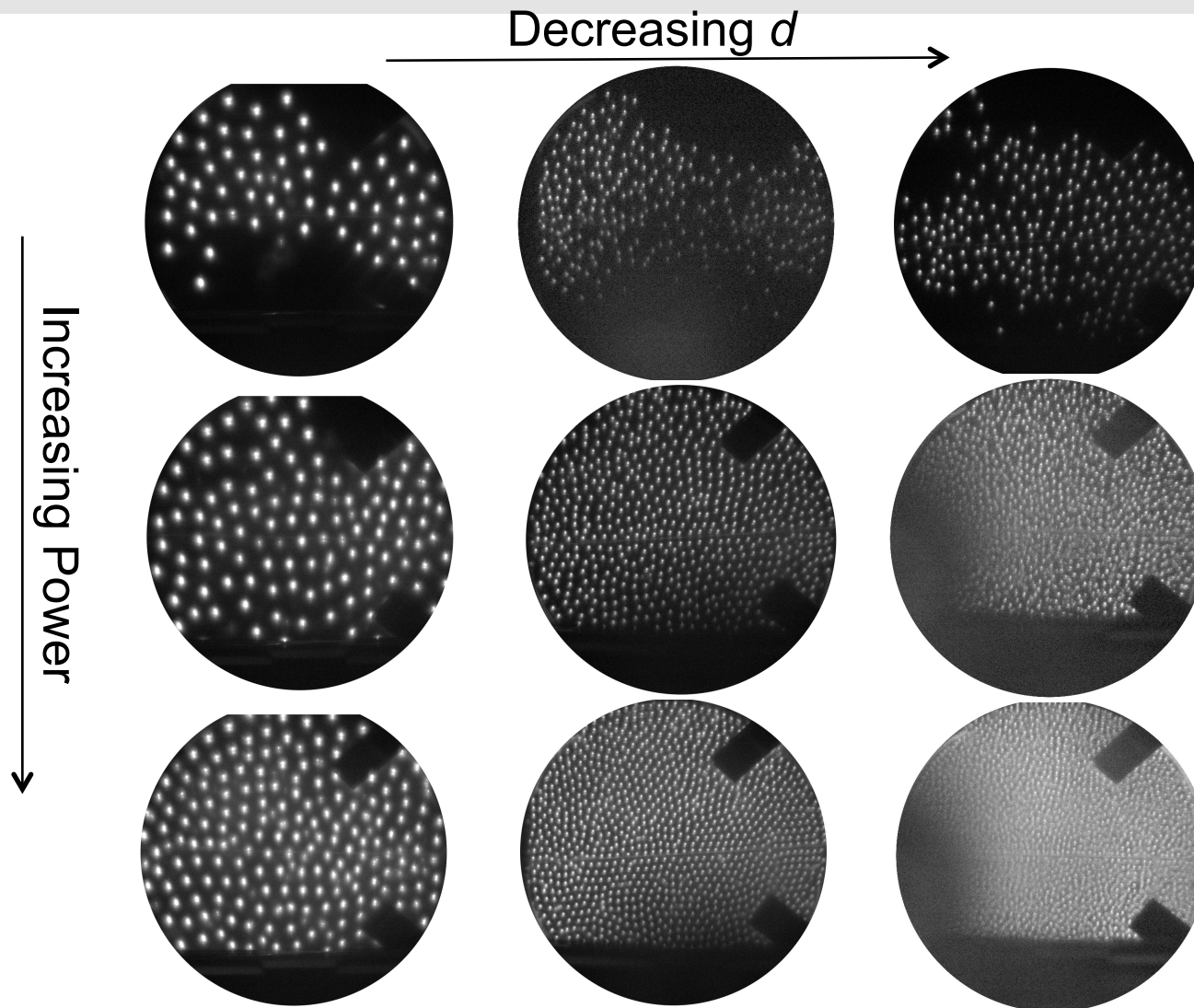


# Experimental Conditions

d (mm)	Static Pressure, $P_s$ (Torr)					Power Gain
2.50	125	200	250	300	400	22-56
1.10	-	200	-	300	400	35-80
0.62	-	-	-	-	400	46-72

- Plasma AC frequency = 54kHz
- Data Acquisition:
  - Sequence of Plasma Lattice Off, On, Off
  - 1001pts.  $S_{21}$ : 17.5 - 20GHz
  - Plasma Lattice Image

# Plasma Lattice Images: $P_s=400\text{Torr}$



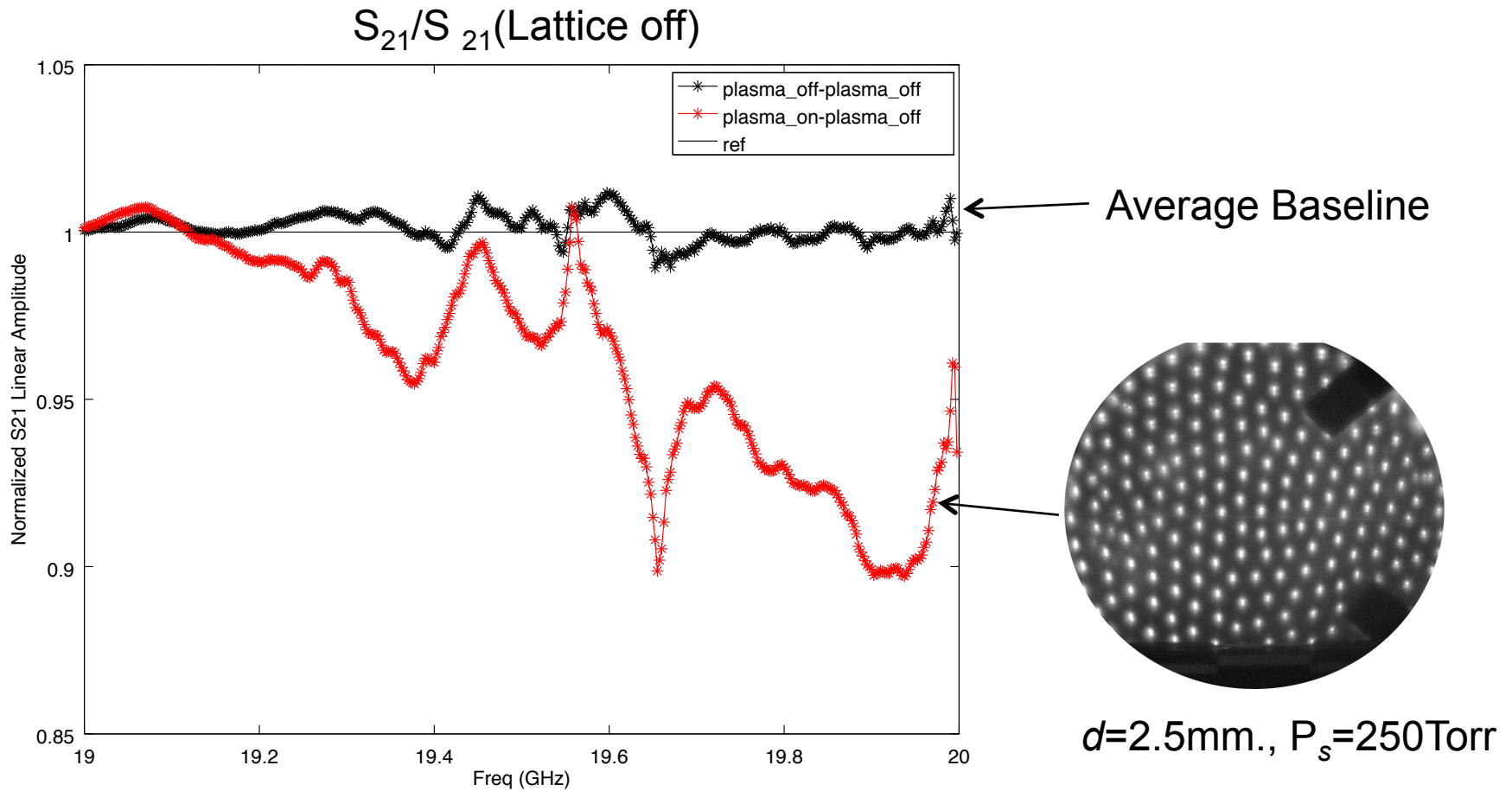
# Image Analysis

Plasma Lattice: $P_s=400\text{Torr}$ , $\omega/2\pi=20\text{GHz}$									
Power Gain	d=2.50(mm)			d=1.11(mm)			d=0.63(mm)		
	a (mm)	$\lambda/a$	$\omega a/2\pi c$	a (mm)	$\lambda/a$	$\omega a/2\pi c$	a (mm)	$\lambda/a$	$\omega a/2\pi c$
Min.	4.7	3.2	0.31	3.2	4.7	0.21	3.0	5.0	0.20
Mid.	4.2	3.6	0.28	2.4	6.2	0.16	2.1	7.1	0.14
Max.	4.6	3.3	0.31	2.0	7.5	0.13	1.6	9.4	0.11

- Metamaterial:  $\lambda/a \approx 10$
- Photonic Crystal:  $\lambda/a \approx 1$
- Band Gap (Sakai et al., 2005):  $\omega a/2\pi c \approx 0.5$

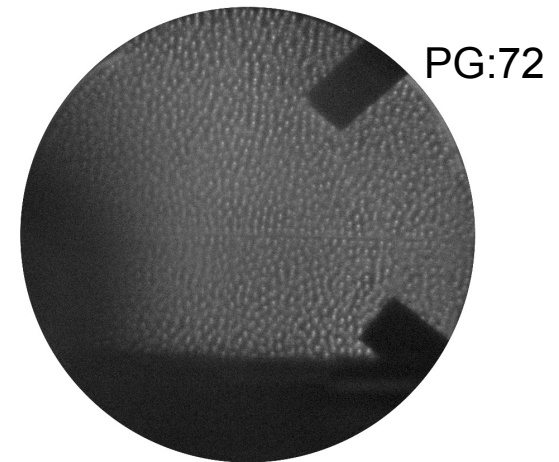
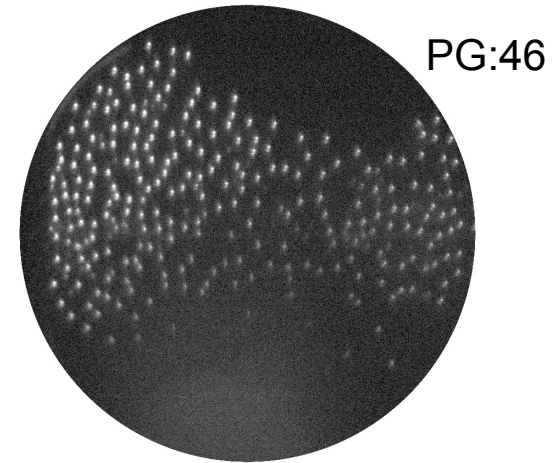
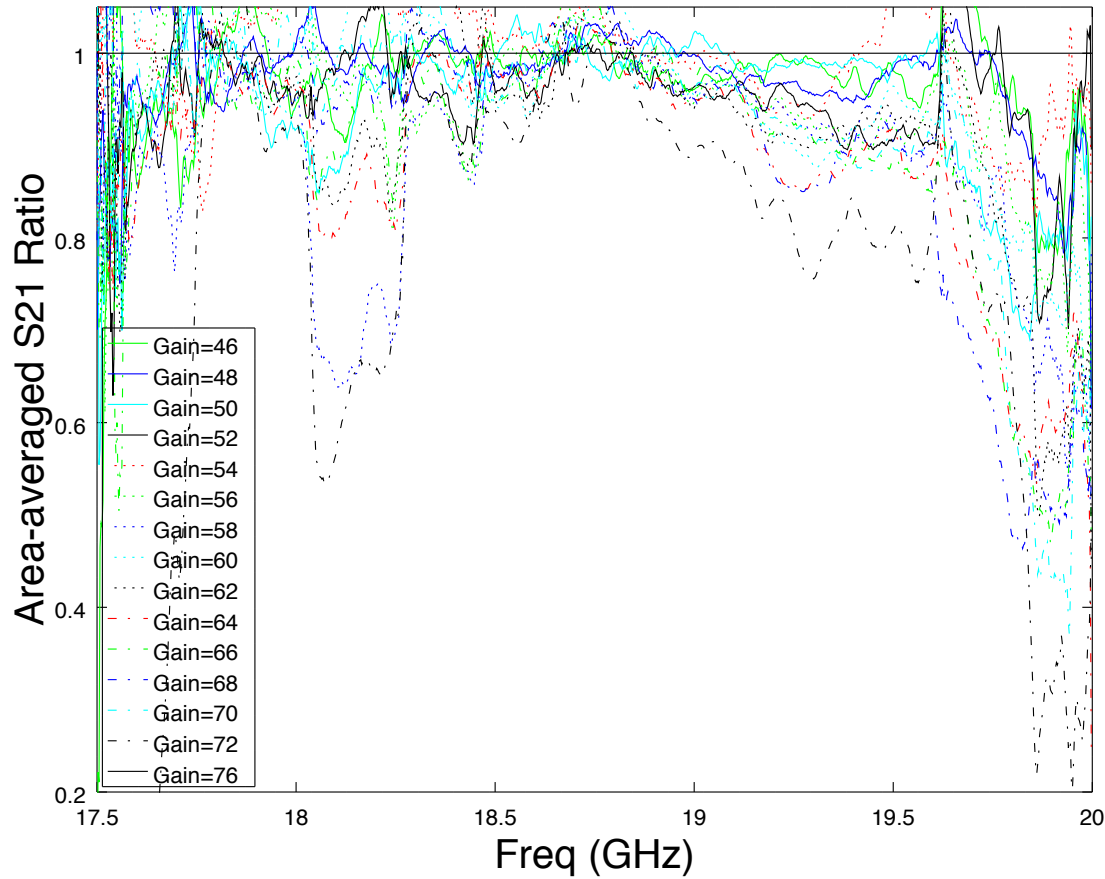


# Sample S<sub>21</sub> Transmittance Spectra



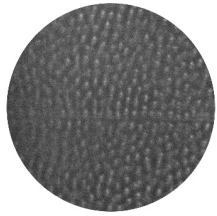
# $S_{21}$ Transmittance Spectra

$P_s=400\text{Torr}$ ,  $d=0.63\text{mm}$ .



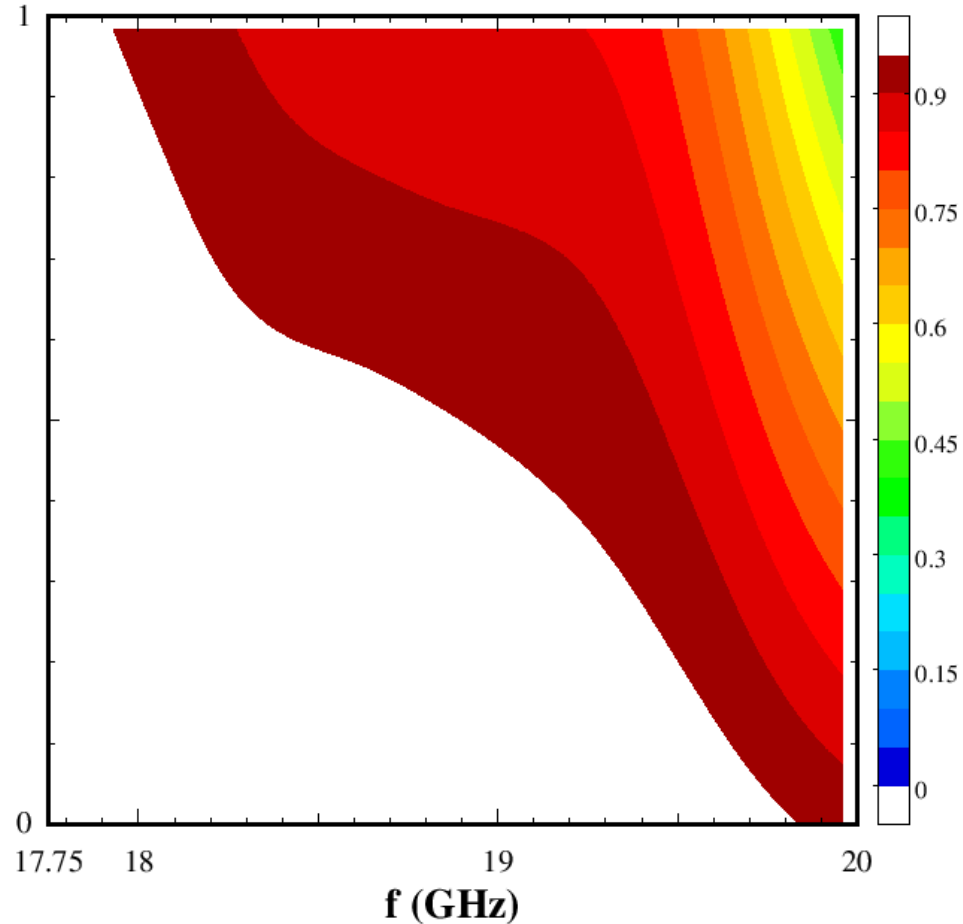
# $S_{21}$ Transmittance Spectra

$P_s=400\text{Torr}$ ,  $d=0.63\text{mm}$ .



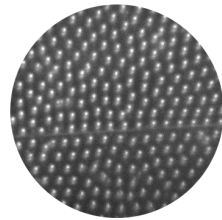
$a$ (mm)	$\lambda/a$	$\omega a / 2\pi c$
3.0	5.0	0.20
2.1	7.1	0.14
1.6	9.4	0.11

$(P_{\text{min}} - P_{\text{max}}) / (P_{\text{max}} - P_{\text{min}})$



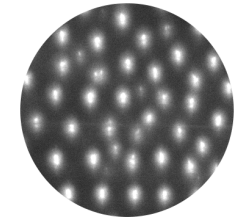
# $S_{21}$ Transmittance Spectra

a (mm)	$\lambda/a$	$\omega a / 2\pi c$
3.2	4.7	0.21
2.4	6.2	0.16
2.0	7.5	0.13

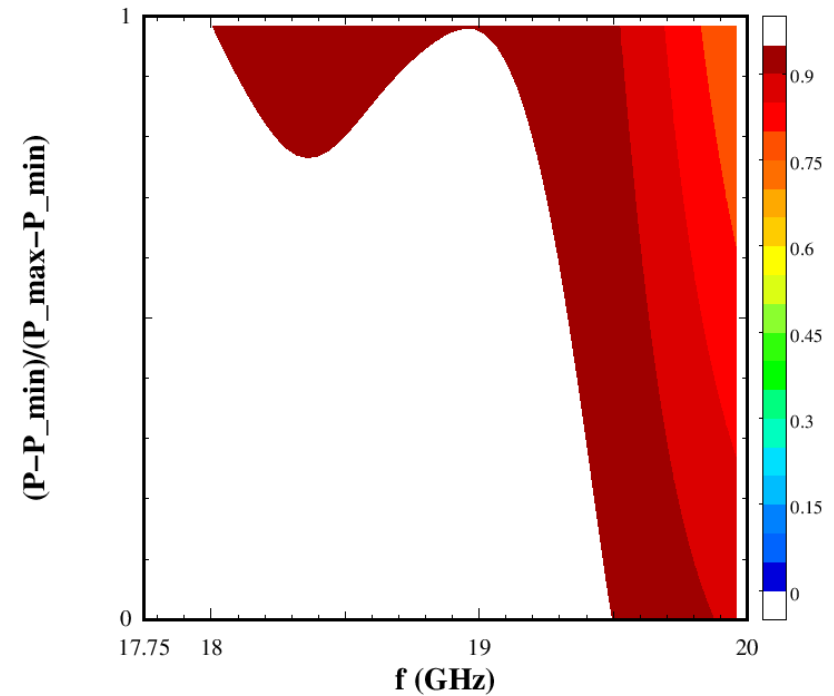
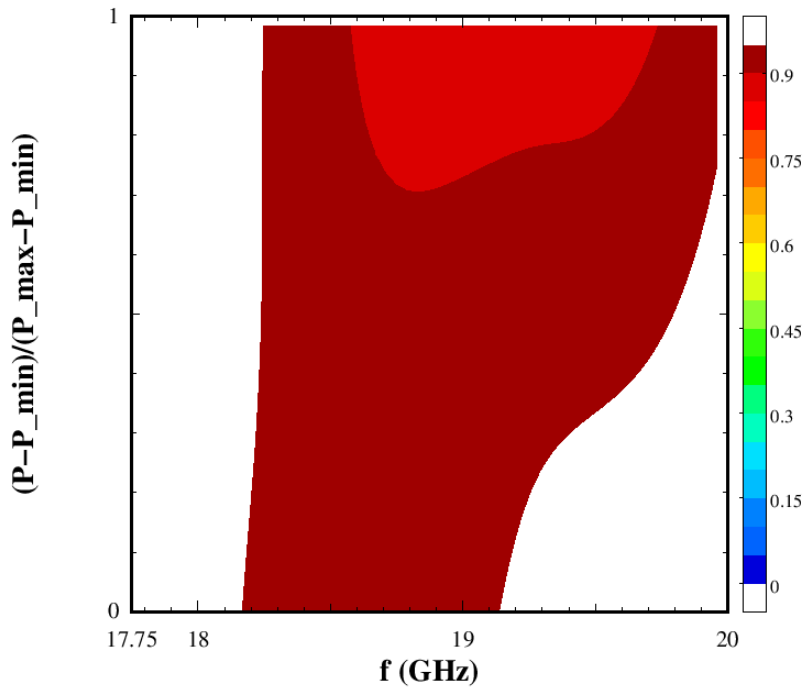


$P_s = 400$  Torr,  
 $d = 1.1$  mm.

a (mm)	$\lambda/a$	$\omega a / 2\pi c$
4.7	3.2	0.31
4.2	3.6	0.28
4.6	3.3	0.31

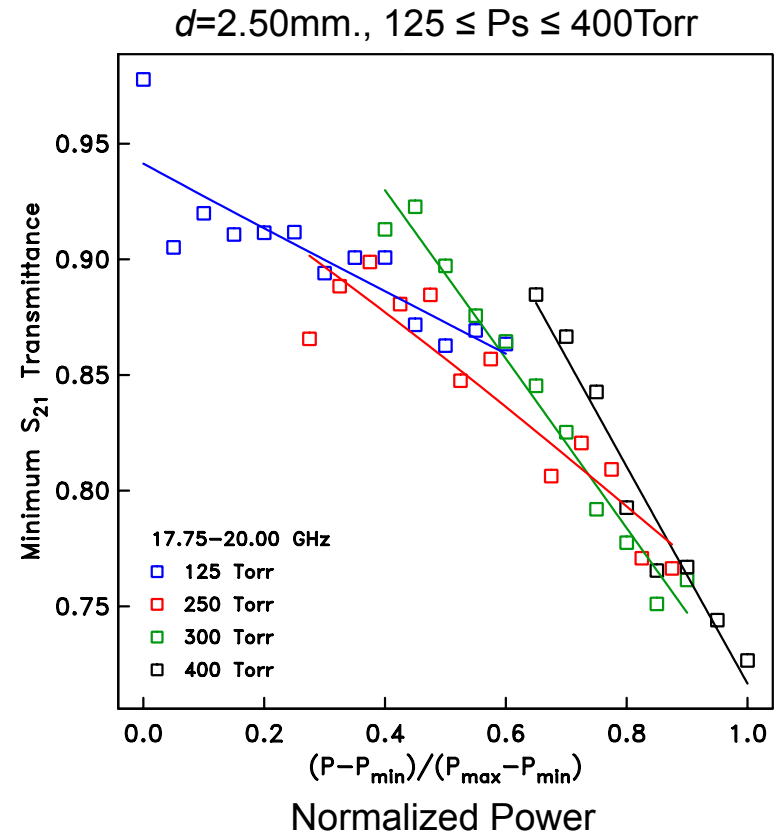
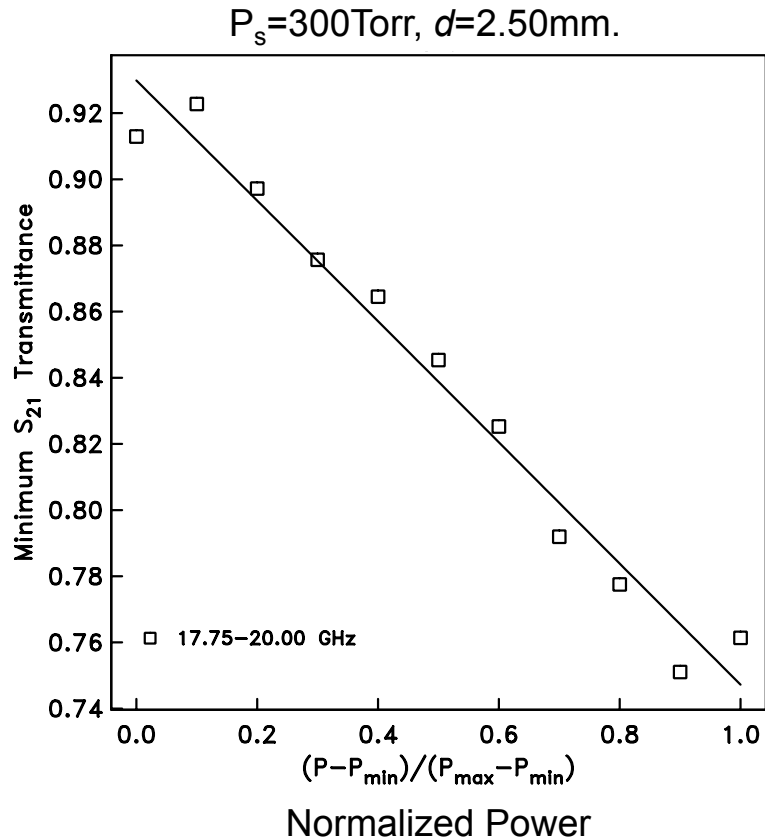


$P_s = 400$  Torr,  
 $d = 2.50$  mm.

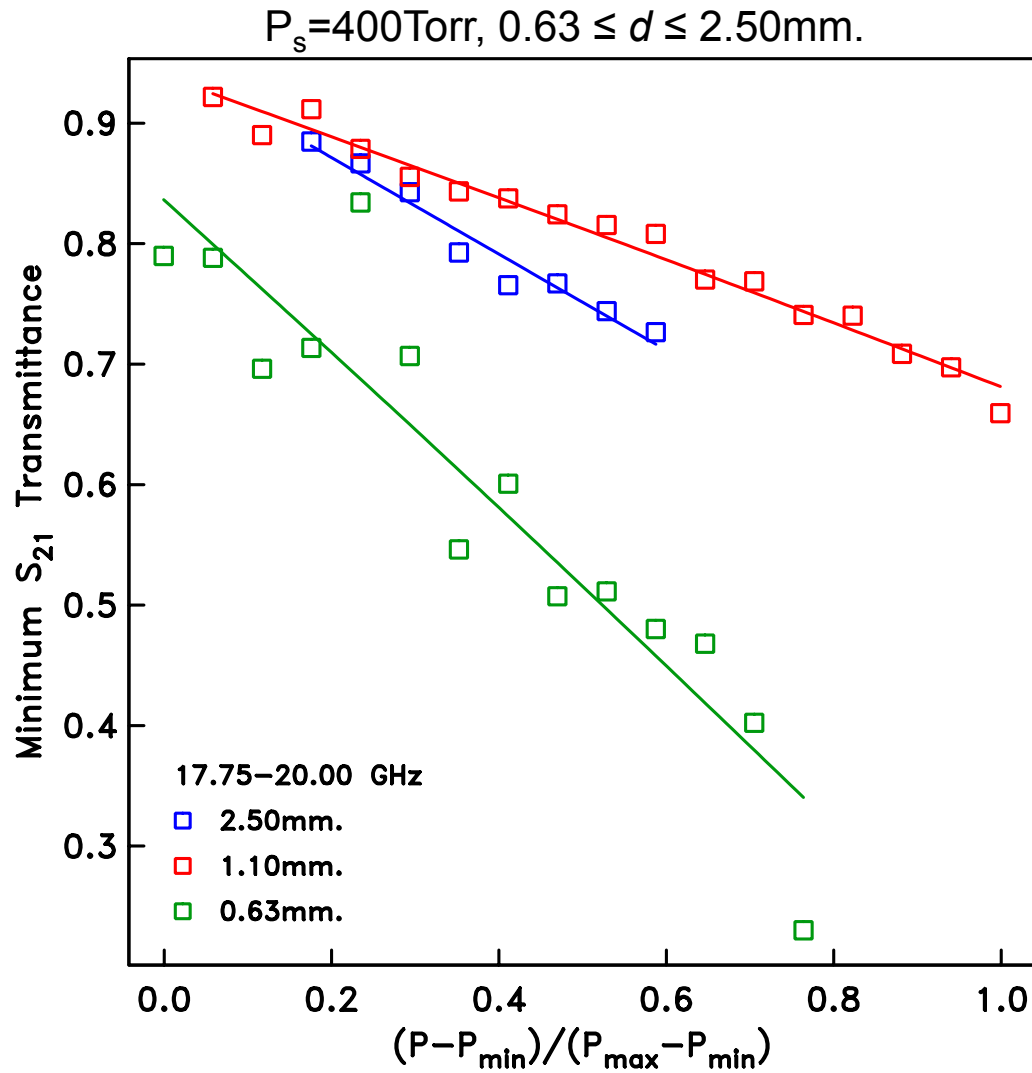




# Effect of Power on Minimum $S_{21}$ Transmittance



# Effect of Gap on $S_{21}$ Minimum Transmittance



# EM Wave Simulation

- Simulation of a 2-D plasma photonic crystal subject to planar electromagnetic wave fronts of a specific probing frequency
- Utilized MIT open-source (Meep) software that solves Maxwell's equations at each time step to realize the electromagnetic field at discrete spatial locations through an implementation of a finite-difference time-domain (FDTD) method.
- Dispersive materials are defined in Meep using a Lorentz-Drude model

$$\epsilon(\omega) = \epsilon_{\infty} + \sum_{m=1}^N \frac{\sigma_m \Omega_m^2}{\Omega_m^2 - \omega^2 + i\nu\omega}$$

Where  $\epsilon_{\infty}$  is the frequency-independent permittivity,  $N$  is the number of resonance frequencies,  $\Omega_m$  is a resonance frequency,  $\sigma_m$  is the strength associated with that frequency, and  $\nu$  is the electron elastic collision frequency.

# Meep: Plasma Column Permittivity

- Permittivity,  $\epsilon_p$ , of each plasma column given by the dispersive relation

$$\epsilon_p(\omega) = 1 - \left(\frac{\omega_p}{\omega}\right)^2 \frac{1}{1 - i\frac{\nu}{\omega}}$$

where  $\omega$  is the probing frequency, and  $\omega_p$  is the plasma frequency and  $\nu$  is the electron elastic collision frequency.

- The plasma frequency is defined as  $\omega_p = \sqrt{\frac{n_e q^2}{m \epsilon_0}}$

where  $n_e$  is the electron density,  $q$  is the electron charge,  $m$  is electron mass, and  $\epsilon_0$  is the free-space permittivity. Based on Razier (1991),  $\nu = (3.9 \times 10^9 \text{ s}^{-1} \text{ Torr}^{-1}) P_s$

- For the Meep parameters, we equate two forms of the permittivity, namely

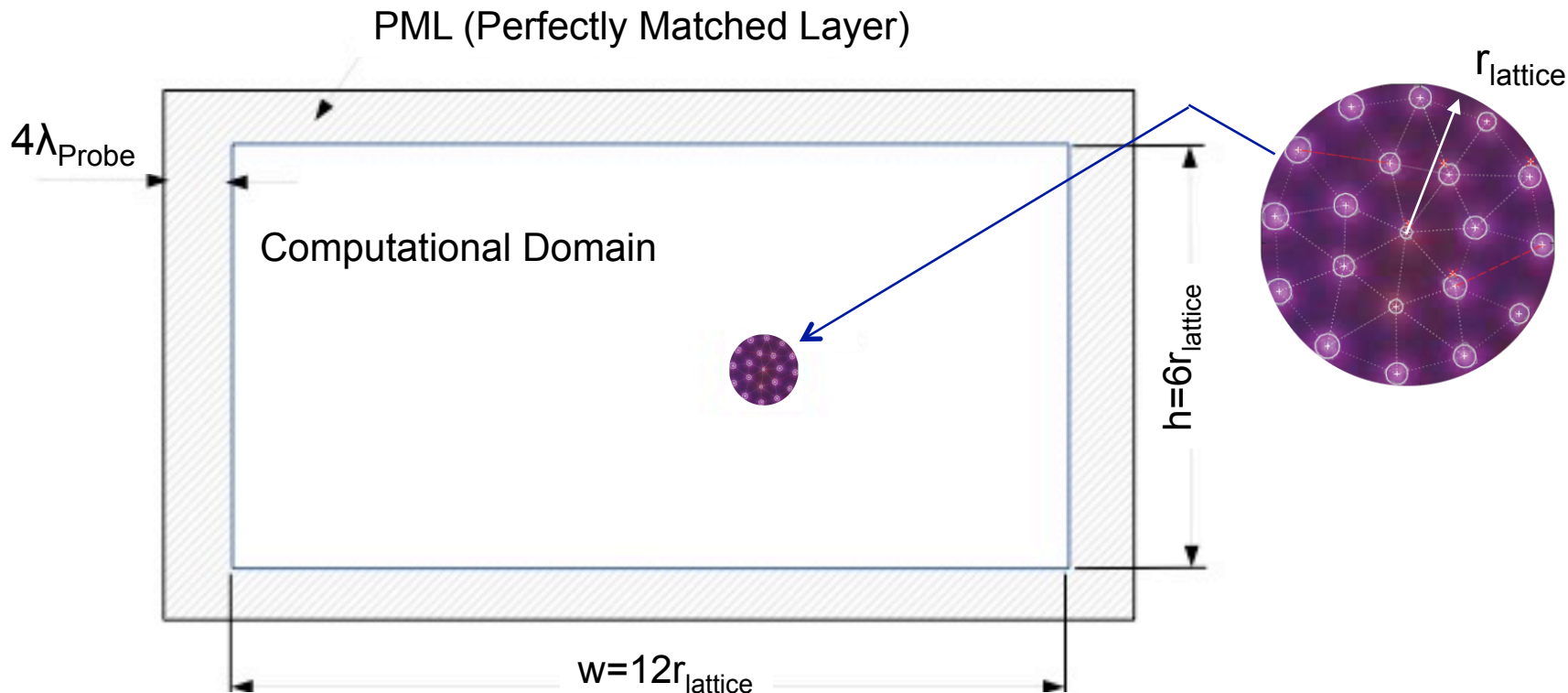
$$\epsilon(\omega) = \epsilon_\infty + \sum_{m=1}^N \frac{\sigma_m \Omega_m^2}{\Omega_m^2 - \omega^2 + i\nu\omega} = 1 + \frac{\omega_p^2}{-\omega^2 + i\nu\omega}$$

then  $\epsilon_\infty = 1$  and  $N = 1$ .

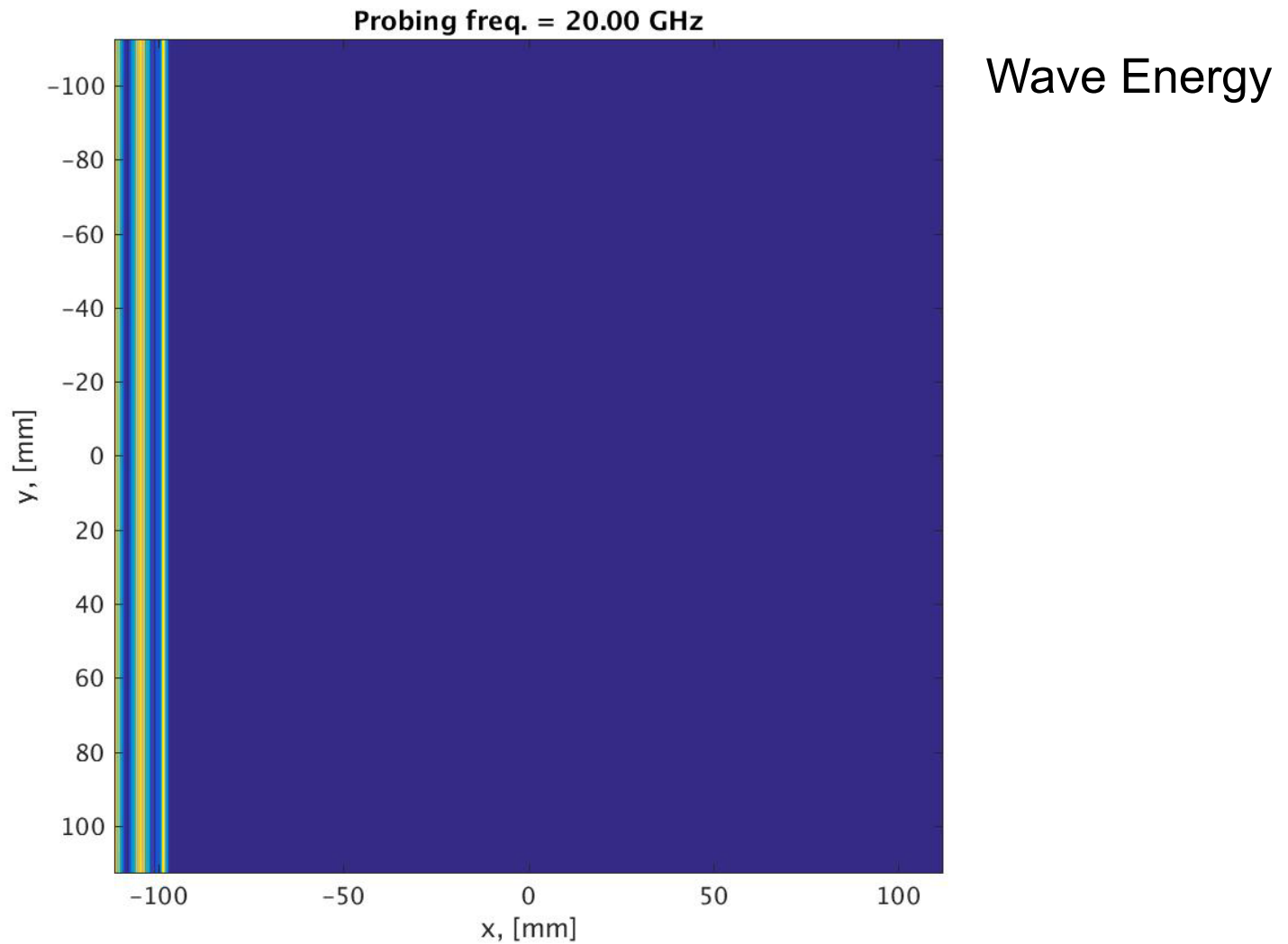
- To achieve the best representation of the plasma material,  $\Omega_m \ll 1$  which requires that  $\sigma_m = (\omega_p)^2 / (\Omega_m)^2$ . Used  $\Omega_m = 0.0001$ .

# EM Wave Simulation

- Computational domain consists of rectangular region  $12r_{\text{lattice}}$  by  $6r_{\text{lattice}}$
- A non-reflecting PML perimeter of width  $4\lambda_{\text{Probe}}$  surrounds the domain
- Plasma grating patterns from the experiments are inset in computational domain

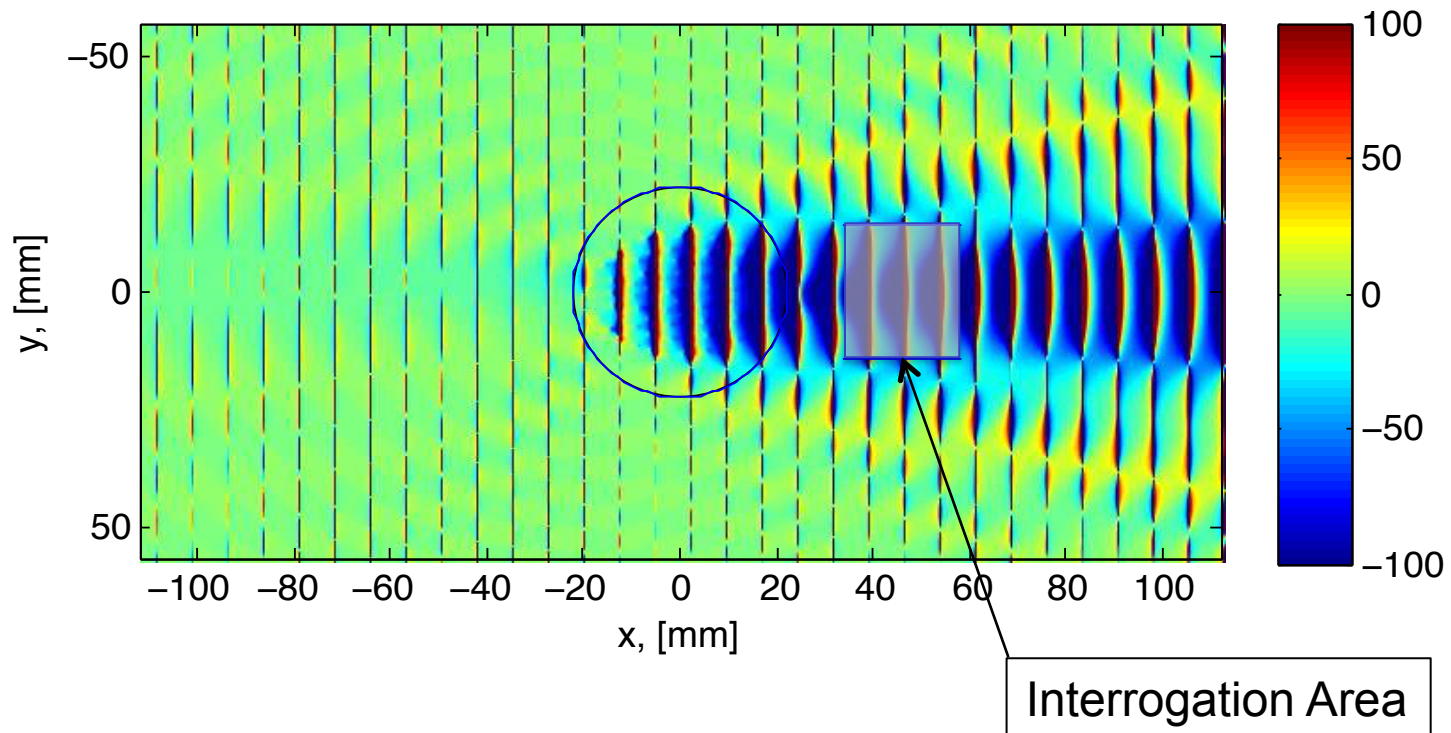


# Simulation: 400 Torr, $a=4\text{mm}$ , $n_e=1\text{e}^{21}\text{m}^{-3}$



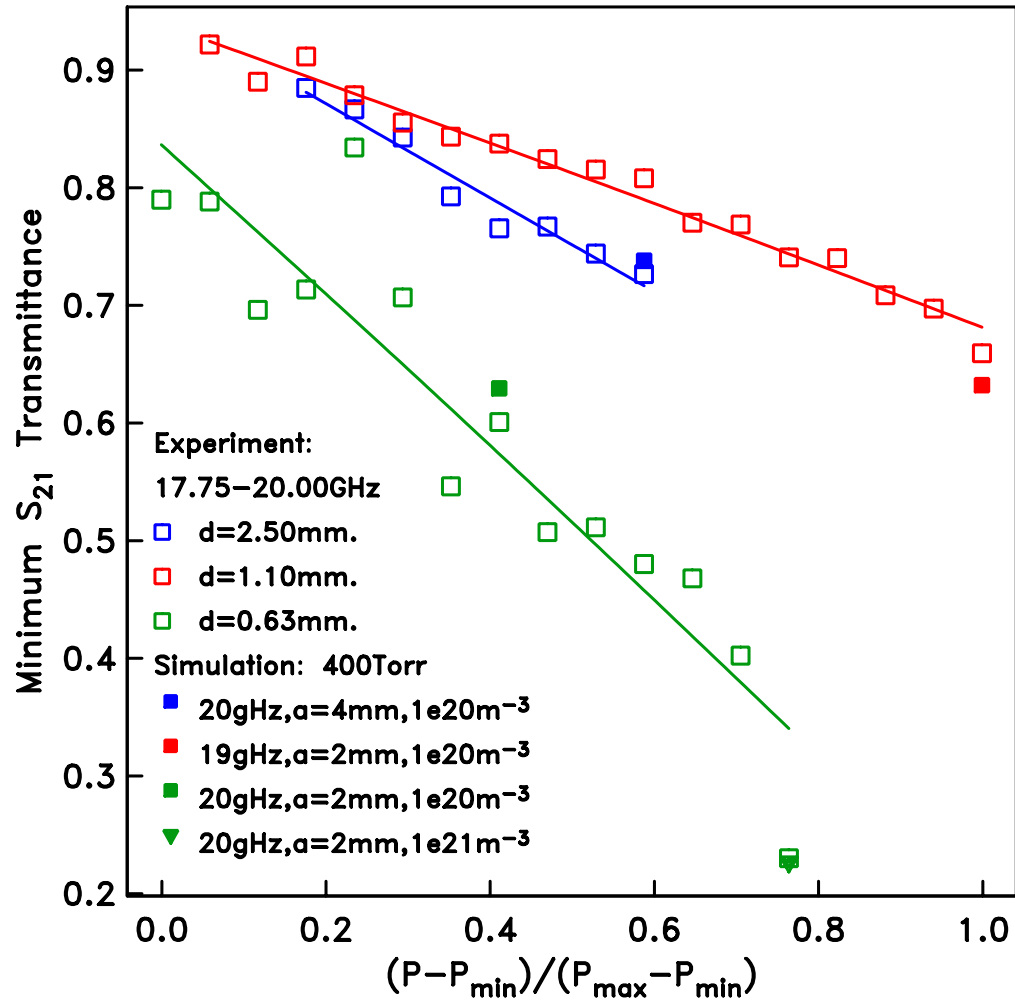
# Simulation: 400 Torr, $a=4\text{mm}$ , $n_e=1\text{e}^{21}\text{m}^{-3}$

$100 \cdot (\text{Plasma} - \text{No Crystal}) / \text{No Crystal}$  at  $n_e=1\text{e}^{21}$ , 4MM, 20GHz



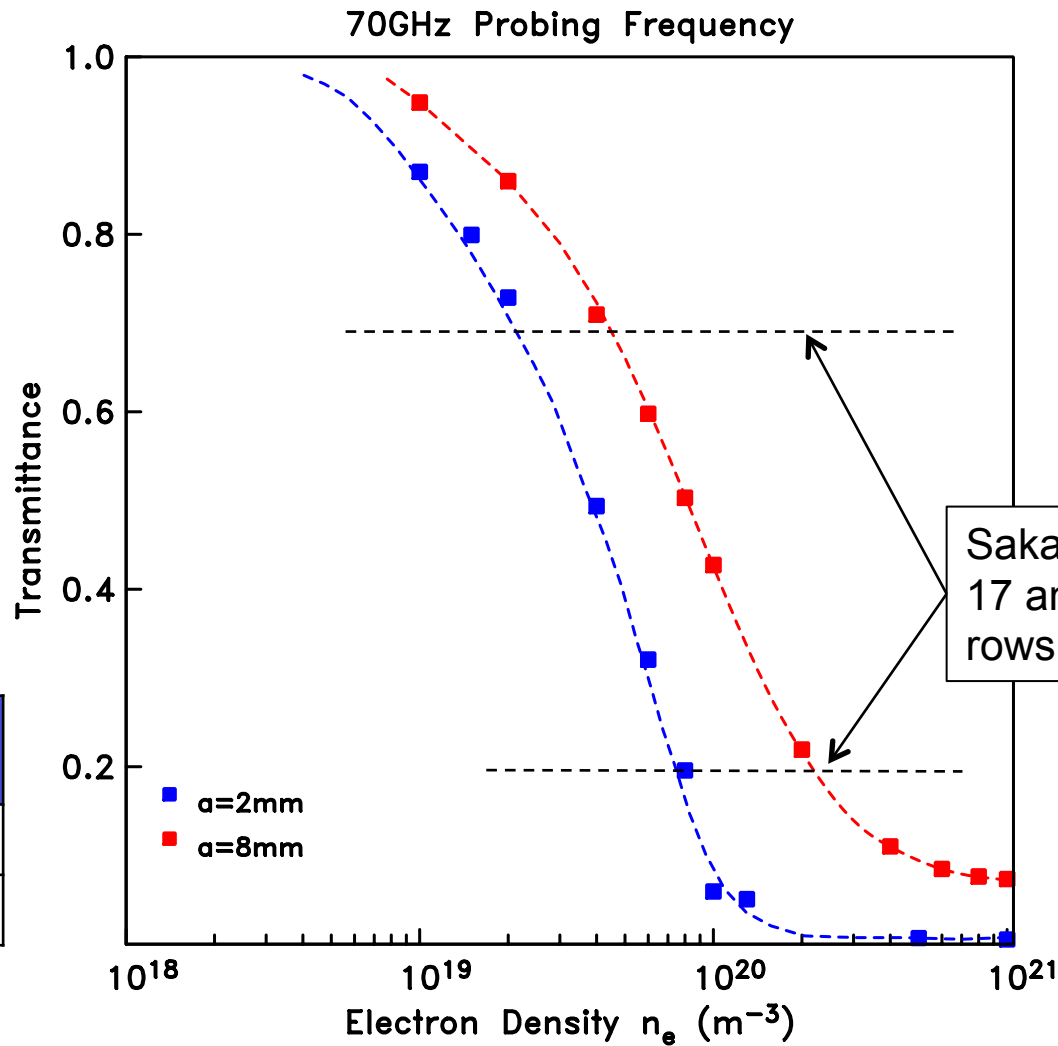
# Simulation Results

$P_s=400\text{Torr}$ ,  $0.63 \leq d \leq 2.50\text{mm}$ .





# Simulation Projection



# Summary

- Demonstrated dynamic control of plasma lattice structures with different lattice spacings,  $a$ .
- Performed EM wave transmittance experiments for probing frequencies up to 20GHz.
- Experiments demonstrated effects of  $P_s$ ,  $d$ , and power on S21 transmittance.
- Results indicated a narrow frequency band S21 attenuation.
- Largest S21 attenuation occurred with highest  $P_s$  were  $\lambda/a=O10$
- The largest attenuation was comparable to other **non-configurable** plasma lattices in the literature, e.g. Sakaguchi et al., 2007.
- EM wave simulations performed on experiment-based plasma lattice configurations produced transmittance values that were in good agreement with the experiments.
  - Indicates validity of the simulation to predict effect at higher probing frequencies.

# Way Forward

- Perform EM wave transmittance experiments at higher probing frequencies (~70GHz).
  - Acquire a 70GHz Vector Network Analyzer and matched components.
- Repeat transmittance measurements at the higher probing frequencies that include off-axis locations.
  - Seek wave energy changes in the  $\Gamma-M$  direction that is a characteristic of a photonic crystal.
- Perform further comparisons to the EM wave simulations.
- Generate band diagrams for a range of lattice spacing and electron densities derived from the experiments. Correlate these to the experimental observations.
- Investigate charge instability lattice control approaches that include:
  - Silicon dielectric with surface layer doping patterns
  - Real-time UV patterns projected on the glass dielectric

} Wave Guides  
and Conduits

# Way Forward

- Even at the current probing frequencies, with our control over the plasma, we are in a position to look at photonic crystals where the columns can have positive, negative or 0 permittivity.
- This is quite unique and we think, **not realizable with non-configurable plasma lattices** in the literature such as that of Sakaguchi et al.